LISTING SHOWING THE AMENDMENT TO THE CLAIMS

This listing replaces all prior listings of claims.

IN THE CLAIMS

Amend the claims as follows:

1 (Currently amended). An electronic component made from primarily organic material, comprising:

a substrate having a depression formed by a laser and/or a lower layer;

[[,]] at least one conductor track and/or electrode in the a depression, produced by a laser, in the substrate and/or the lower layer, which the depression having has steep walls, sharp contours and a relatively rough bottom surface, the at least one conductor track and/or electrode comprising at least one conductive material that is applied in two layers and-can-be-introduced by one or more desired methods in order to apply conductive layers over a relatively large area.

- 2 (Currently amended). The electronic component as claimed in claim 1, having <u>at least two conductor tracks and at least two electrodes and a distance I smaller than 10 μm between the two conductor tracks, the <u>at least two electrodes and/or between a conductor track and an electrode</u>.</u>
- 3 (Currently amended). The electronic component as claimed in <u>claim 1 wherein</u> ene of the preceding claims, in which the two-layer material of the conductor track and/or electrode comprises at least one metallic layer or one layer made from an alloy.

- 4 (Currently amended). The electronic component as claimed in <u>claim 1 wherein</u> one of the preceding claims, in which at least one layer of the at least two-layer material is made from organic material.
- 5 (Currently amended). A method for producing an organic electronic component with a conductor track or electrode, the component in having a lower layer and/or a substrate, the method which, in order to produce a conductor track and/or an electrode, a lower layer and/or the substrate are/is treated comprising treating the lower layer and/or substrate with a laser such that at least one depression and/or one modified region are formed are/is to be found in the a lower layer and/or the substrate, then filling the depression and/or modified region which is filled sequentially with conductive material in at least two layers to thereby produce the conductor track and/or electrode.
- 6 (Currently amended). The method as claimed in claim 6, <u>including the step of</u>

 <u>mechanically structuring in which</u> the conductive layer is <u>mechanically structured</u>.
- 7 (Currently amended). The method as claimed in <u>claim 5 in which superfluous</u>

 <u>conductive material is produced, either of claims 6 and 7, in which the method</u>

 <u>including wiping off the superfluous conductive material is wiped off in a process step</u>

 following the application of the layer-made from this material.
- 8 (Currently amended). The method as claimed in one of claims 6 to 8, claim 6 in which a pulsed laser, for example an excimer laser, is used to form the at least one depression and/or one modified region.

9 (Currently amended). The method as claimed in one of claims 6 to 9, claim 6 which is carried out in a continuous roll-to-roll process.